

Abstract Submitted  
for the MAR06 Meeting of  
The American Physical Society

**Self-Assembled Unstrained InGaAs Quantum Dashes** ALEXANDER UKHANOV, US Naval Research Laboratory, ALLAN BRACKER, GEORO BOISHIN, JOE TISCHLER, JIM CULBERTSON — We describe a technique for MBE-based fabrication of unstrained quantum dashes with  $\text{Al}_x\text{In}_y\text{Ga}_{1-x-y}\text{As}$  alloys lattice-matched to InP substrates. Templates for lattice-matched quantum dash growth are obtained by combining molecular beam epitaxy with *in situ* etching by arsenic bromide. A seed layer of self-assembled InAs quantum dashes is converted into nanotrench templates through overgrowth followed by strain-enhanced etching. We have explored limitations on the accessible range of alloy compositions imposed by the etch process and found that strain-induced etching is limited to compounds with low Al content. Nanotrench templates can be filled with lattice-matched alloys of varied compositions to define barriers and quantum wires that could lead to optoelectronic devices in a spectral range around  $1.5 \mu\text{m}$ . Here we also present Atomic Force Microscopy and Photoluminescence data obtained from self assembled unstrained  $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$  Quantum Dashes.

Alexander Ukhanov  
US Naval Research Laboratory

Date submitted: 05 Dec 2005

Electronic form version 1.4